

[54] SEMICONDUCTOR

[75] Inventors: **Hidetoshi Mochizuki, Fuchu; Keizo Otsuki, Higashiyamayo; Hideki Kosaka, Kodaira; Gen Murakami, Machida, all of Japan**

[73] Assignee: **Hitachi, Ltd., Tokyo, Japan**

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[58] Field of Search ..... **D13/12, 99, 40, 41;**  
**174/52 R, 52 PE, 52 S, 52 FP, 50.5, 50.52,**  
**50.56; 357/70, 73, 74, 80**

[56]

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Primary Examiner—Susan J. Lucas  
Attorney, Agent, or Firm—Craig and Antonelli

[57]

CLAIM

The ornamental design for a semiconductor, as shown.

DESCRIPTION

FIG. 1 is a right side, top and front perspective view of a semiconductor showing our new design.

FIG. 2 is a rear elevational view thereof;

FIG. 3 is a left side view thereof;

FIG. 4 is a bottom view thereof.

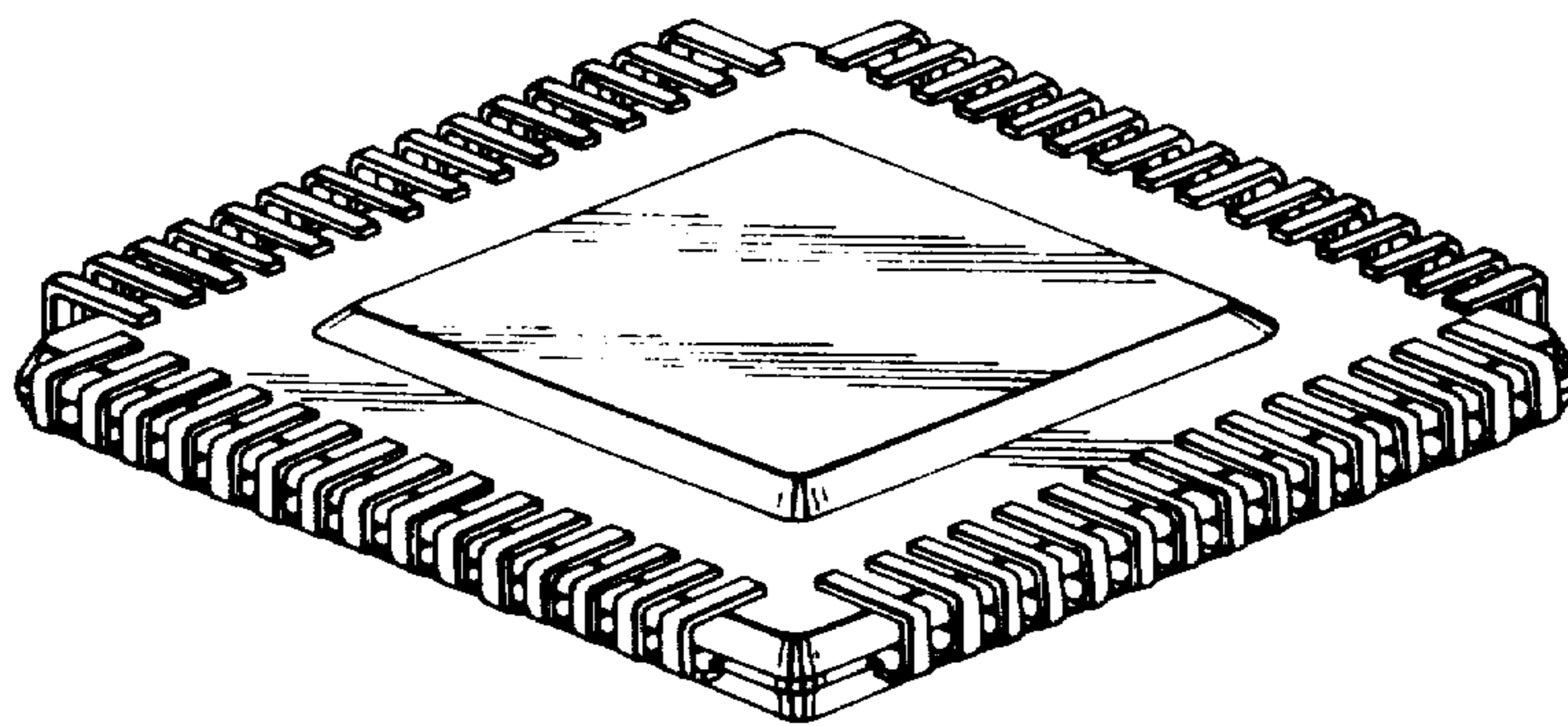


FIG. 1

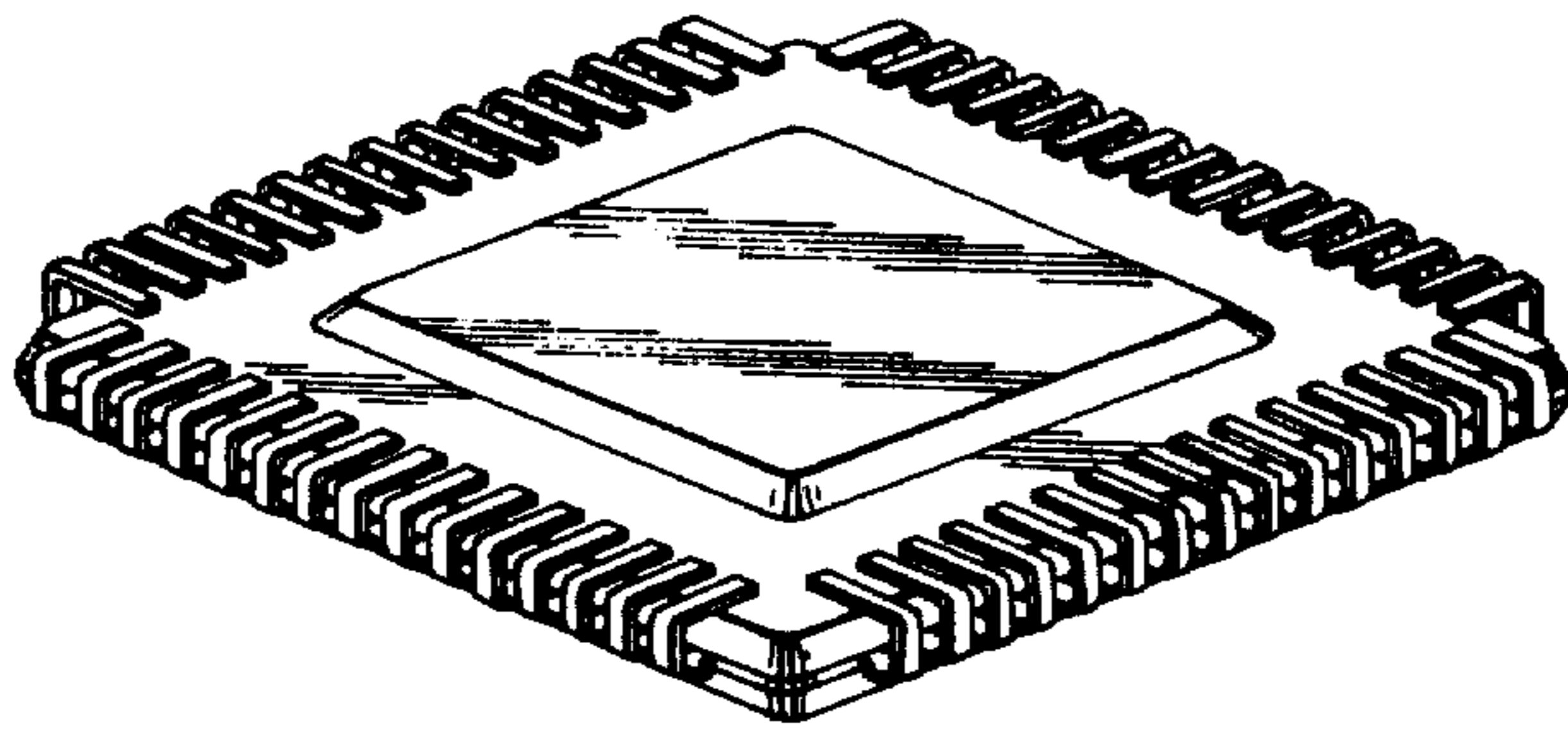


FIG. 2



FIG. 3



FIG. 4

